



Contribution ID: 590

Type: not specified

## Development of HVCMOS in 55 nm Process for Tracing [Zoom]

Thursday 18 January 2024 09:30 (30 minutes)

### Scheduling Preferences

**My talk would be conducted**

**Primary author:** LI, Yiming (IHEP; Via Zoom)

**Presenter:** LI, Yiming (IHEP; Via Zoom)

**Session Classification:** Mini-workshop: Experiment/Detector